

<b>Notice of References Cited</b>	Application/Control No. 10/649,002	Applicant(s)/Patent Under Reexamination KIM, JAE-HWAN	
	Examiner Dai A. Phuong	Art Unit 2688	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0111139 A1	08-2002	Nishiyama et al.	455/41
*	B	US-2004/0171363 A1	09-2004	Minakuchi, Mitsuru	455/170.1
*	C	US-5,724,492	03-1998	Matthews et al.	345/419
*	D	US-2001/0006388	07-2001	Kim et al.	345/418
*	E	US-2001/0053708	12-2001	Sugiyama et al.	455/566
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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